



LIST OF REFERENCES CITED BY APPLICANT		ATTY. DOCKET NO 9840-0068-999	APPL. NO. 10/076,296
(Use several sheets if necessary)		APPLICANT Conant et al.	
		PFLNG DATE February 13, 2002	GRANT # 1765 To be assigned

U.S. PATENT DOCUMENTS

EXAMINER NAME		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	PFLNG DATE IF APPROPRIATE
AA	AA	6,201,629	3/13/01	McClelland et al.			
AB	AB	5,959,760	9/28/99	Yamada et al.			

RECEIVED
JUL 25 2002
TC 1700

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
AC	AC	PCT/US01/15514	5/14/01	PCT Int'l Search Report			

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

AD	Kam Y. Lau, "Microscanner Raster-scanning Display: A Spyglass for the Future", Optics & Photonic News, May 1999 Vol.. 10 No. 5, pages 47-50, 84
AE	Nee et al. "Stretched-Film Micromirrors For Improved Optical Flatness", IEEE MEMS 2000 Conference, January 23-27 2000 Miyazaki, Japan
AF	Conant et al. "Robustness and Reliability of Micromachined Scanning Mirrors", MOEMS '99, Mainz Germany, August 1999
AG	Hagelin et al. "Integrated Micromachined Scanning Display Systems", presented at 18 th Congress of the International Commission for Optics, San Francisco, CA, August 1999
AH	Conant et al. "A Raster-Scanning Full-Motion Video Display Using Polysilicon Micromachined Mirrors", proc. Transducers '99, Sendai, Japan, June 1999, pp. 376-379
AI	Hart et al. "Time-Resolved Measurement of Optical Mems Using Stroboscopic Interferometry", proc. Transducers '99, Sendai, Japan, June 1999, pp. 470-473
AJ	Nee et al. "Scanning Blazed-Grating for High-Resolution Spectroscopy", 1998 Workshop for Solid State Sensors and Actuators (HH '98) Late News Poster Session Supplemental Digest, Hilton Head Island, June 8-11, 1998, pgs. 9-10
AK	Kiang et al. "Surface-Micromachined Diffraction Gratings for Scanning Spectroscopic Application", proc. Transducers '99, Sendai, Japan, June 1999, pp. 998-1001
AL	Nee et al. "Lightweight, Optically Flat Micromirrors for Fast Beam Steering". IEEE/LEOS Optical MEMS 2000, Kauai, Hawaii, August 21-24, 2000
AM	Conant et al. "A Flat High-Frequency Scanning Micromirror". 2000 Workshop for Solid State Sensors and Actuators (HH2000), Hilton Head Island, SC, USA, June 4-8, 2000, pp. 6-9, Digest of Technical Papers

EXAMINER <i>Conant</i>	DATE CONSIDERED <i>6/16/03</i>
---------------------------	-----------------------------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.